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CONFIRMATION NO. 2937

SERIAL NUMBER 10/586,476	FILING or 371(c) DATE 07/18/2006 RULE	CLASS 117	GROUP ART UNIT 1792	ATTORNEY DOCKET NO. 128768	
APPLICANTS Makoto Iida, Fukushima, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP05/00641 01/20/2005 ** FOREIGN APPLICATIONS ***** JAPAN 2004-026887 02/03/2004 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 07/09/2007					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input type="checkbox"/> Yes <input checked="" type="checkbox"/> No Verified and /G. NAGESH NAGESH RAO/ Acknowledged Examiner's Signature	<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 3	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
ADDRESS OLIFF & BERRIDGE, PLC P.O. BOX 320850 ALEXANDRIA, VA 22320-4850 UNITED STATES					
TITLE Method for Producing Semiconductor Wafers and a System for Determining a Cut Position in a Semiconductor Ingot					
FILING FEE RECEIVED 900	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		